

Chapter 19: Carbonyl Compounds III

Learning Objectives:

1. Write the mechanism for keto-enol tautomerization and explain the consequence of such tautomerization in the optical chirality of compound.
2. Remember the approximate pK_a value for the α -hydrogen of a carbonyl group.
3. Provide appropriate bases for the formation of enolate and use such enolate for halogenation and alkylation.
4. Be able to write the general electron-pushing (arrow-pushing) mechanisms of Aldol reaction, Michael reaction, Claisen condensation, and Dieckmann condensation.
5. Be able to write the general electron-pushing (arrow-pushing) mechanisms for decarboxylation of β -oxocarboxylic acids
6. Be able to employ the above-mentioned reaction for the formation of new carbon-carbon bond

Sections to be covered (in the order of delivery):

- 19.1 Acidity of α -hydrogens*
- 19.2 Keto-Enol Tautomerism*
- 19.3 How Enols and Enolate Ions React*
- 19.4 Halogenation of the α -Carbon of Aldehydes and Ketones*
- 19.5 Halogenation of the α -Carbon of Carboxylic Acids: The Hell-Volhard-Zelinski (HVE) Reaction
- 19.6 α -Halogenated Carbonyl Compounds in Synthesis*
- 19.7 Using LDA to form an Enolate*
- 19.8 Alkylation of the α -Carbon of Carbonyl Compounds*
- 19.9 Alkylation and Acylation of the α -Carbon via an Enamine Intermediate
- 19.10 Alkylation of the β -Carbon: the Michael Reaction*
- 19.11 The Aldol Reaction*
- 19.12 Dehydration of Aldol Addition Products: Formation of α,β -Unsaturated Aldehydes and Ketones*
- 19.13 The Mixed Aldol Reaction
- 19.14 The Claisen Condensation*
- 19.15 The Mixed Claisen Condensation
- 19.16 Intramolecular Condensation and Addition Reactions*
- 19.17 Decarboxylation of β -Oxocarboxylic Acids*
- 19.18 The Malonic Ester Synthesis: Synthesis of Carboxylic Acids
- 19.19 The Acetoacetic Ester Synthesis: Synthesis of Methyl Ketones
- 19.20 Designing a Synthesis VI: Making New Carbon-Carbon Bonds

* Sections that will be focused

Recommended additional problems

19.44 – 19.52, 19.54 – 19.64, 19.66 – 19.80